



ABSTRACT OF THE DISCLOSURE

~~To provide~~The invention provides a material arranging method, a film-forming apparatus, an electro-optical device and a manufacturing method thereof, an electronic device, and an electronic apparatus, capable of rapidly detecting a ejection failure of a nozzle, accomplishing reduction of defectives, and always stabilizing a state in which material is ejected. A film-forming apparatus according to the present invention ~~comprises~~can include a pressure control system ~~12~~ for controlling the pressure in a vacuum chamber (processing chamber) ~~11~~ to a low pressure, at least one nozzle ~~15~~ for arranging material on a base (member) ~~14~~, a base stage ~~13~~ for holding the base ~~14~~, a driving system (moving means) ~~17~~ for relatively moving a position of the nozzle ~~15~~ or the base stage ~~13~~, and a detecting system (an inspecting means~~device~~) ~~19~~ for inspecting the material arranged on the base ~~14~~.